## Notice of References Cited Application/Control No. 10/511,792 Examiner Chris C. Chu Applicant(s)/Patent Under Reexamination RADENNE ET AL. Page 1 of 1

## U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-5,975,420	11-1999	Gogami et al.	235/492
*	В	US-5,637,858	06-1997	Hoppe et al.	235/492
*	С	US-5,736,781	04-1998	Atsumi, Shiro	257/679
*	D	US-5,067,008	11-1991	Yanaka et al.	257/703
*	E	US-4,961,105	10-1990	Yamamoto, Hiroshi	257/679
*	F	US-4,649,418	03-1987	Uden, Edward	257/679
*	G	US-4,264,917	04-1981	Ugon, Michel	257/668
*	Н	US-6,301,119	10-2001	Thevenot et al.	361/737
*	ı	US-4,841,134	06-1989	Hida et al.	235/488
	J	US-			
	К	US-			
	L	US-			
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Ρ					
	a					
	R					
	s					
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	υ	
	>	
	8	
	x	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates, Classifications may be US or foreign.